

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

icant: Shinji Maekawa

Art Unit: 2813

rial No.: 09/724,403 🖊

Examiner: Yennhu B. Huynh

Filed

: November 27, 2000

Title

: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH

TENSILE STRESS (AS AMENDED)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PETITION FOR ONE-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated June 19, 2003, be extended for one month to and including October 19, 2003.

Enclosed is a check for \$110 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

10/20/03 Date:

John F. Hayden Reg. No. 37,640

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